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Application No. 10/700,516
Docket No. 740756-2666

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Shunpei YAMAZAKI et al.)
Serial No. 10/700,516)
Filed: November 5, 2003)
For: LASER IRRADIATION APPARATUS AND METHOD)
OF FABRICATION SEMICONDUCTOR DEVICE)

Examiner: Stephen Smooth
Group Art Unit: 2813

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or being facsimile transmitted to the USPTO at 571-273-1692, on January 10, 2006.

Signature: _____

Name: Pamela L. Patrick

CORRECTED INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Further to the IDS filed September 29, 2005, Applicants submit herewith a corrected form PTO-1449. It is noted that US2003/0129790A1 to Yamazaki et al. (published July 10, 2003) was incorrectly listed in the previously filed form PTO-1449 as US2003/012790.

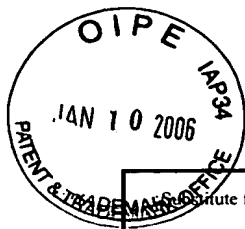
Applicants sincerely appreciate the Examiner bringing this typographical error to Applicants' attention and allowing Applicants an opportunity to rectify the error.

Respectfully submitted,

By: _____


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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Complete if Known	
		Application Number	10/700,516
		Filing Date	November 5, 2003
		First Named Inventor	Shunpei YAMAZAKI et al.
		Art Unit	2813
		Examiner Name	Yennhu B. Huynh
Sheet	1	of	1
		Attorney Docket Number	740756-2666

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
		US-2003/0129790 A1	07/10/2003	Yamazaki et al.	
		US-			
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
		JP2004-039890 A	02/05/2004	Yamazaki		AB
		JP2004-179356 A	06/24/2004	Yamazaki et al.		AB
		JP2004-289140 A	10/14/2004	Moriwaka et al.		AB

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.